APPM/008539/TSG/EPI/RKK UNASSIGNED ATTY DKT. No.:

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APPLICANT: TITLE:

APPLIED MATERIALS, INC.
METHODS OF SELECTIVE DEPOSITION OF HEAVILY DOPED EPITAXIAL

SIGE

INVENTOR: KIM, ET AL

 $\Gamma$ 

EXPRESS MAIL NO .: EV 351031209 US

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CONF. NO .: UNKNOWN

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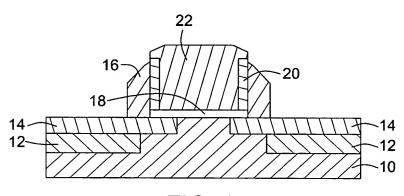


FIG. 1A

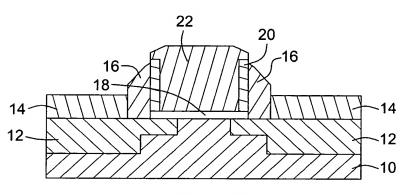
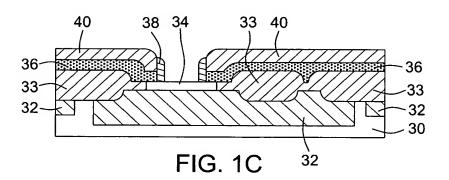


FIG. 1B



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